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Response After Final Rejection  
Group Art Unit 2879, Expedited Procedure

03500.013314.2

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TOSHIKAZU ONISHI, ET AL.

Application No.: 10/014,131

Filed: December 13, 2001

For: METHOD FOR  
MANUFACTURING ELECTRON  
EMISSION ELEMENT,  
ELECTRON SOURCE, AND  
IMAGE FORMING APPARATUS )

Examiner: K. Ramsey

Group Art Unit: 2879

September 30, 2003

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Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

REQUEST FOR RECONSIDERATION AFTER FINAL REJECTION

Sir:

This Request For Reconsideration is filed in response to the Office Action  
(Paper No. 7) of June 30, 2003. Applicants submit the following comments in response to the  
Office Action.

I hereby certify that this correspondence is being deposited with the  
United States Postal Service as first-class mail in an envelope  
addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria,  
VA 22313-1450 on September 30, 2003.

(Date of Deposit)

FRANK A. DeLUCIA, JR. (REG. #42,476)

(Name of Attorney for Applicant)

*Frank A. DeLucia, Jr.*  
Signature

September 30, 2003

Date of Signature